

Special Issue

CMOS Biosensor and Bioelectronic

Message from the Guest Editors

The rapid advancements in complementary metal-oxide-semiconductor (CMOS) processes have facilitated the integration of the analog sensing front end into an IC chip, making it a viable option. It has emerged as the predominant choice for manufacturing next-generation custom microdevices. The advancement of CMOS high-density microelectrode arrays has significantly streamlined the closed-loop System-on-Chip (SoC) recording of electrical signals from larger areas and entire cell populations. In this configuration, multiple electrodes are strategically distributed across a substantial area, enabling simultaneous recording of functions from thousands of cells. This versatile capability finds utility in both in vivo implantation and in vitro cell cultures and tissue preparations, broadening its potential applications in both academic research and industrial domains. For this Special Issue, our primary objective is to comprehensively cover the latest advances and progress in CMOS bioelectronics and its various applications. High-quality research articles, communications, and reviews are welcome for submission.

Guest Editors

Dr. Fuze Jiang

Department of Information Technology and Electrical Engineering, ETH Zurich, CH-8093 Zürich, Switzerland

Prof. Dr. Ha-Duong Ngo

Hochschule für Technik und Wirtschaft Berlin, University of Applied Sciences, Treskowallee 8, 10318 Berlin, Germany

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Editorial Office
MDPI, Grosspeteranlage 5
4052 Basel, Switzerland
Tel: +41 61 683 77 34
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Editor-in-Chief

Prof. Dr. Ai-Qun Liu

1. Department of Electrical and Electronic Engineering, The Hong Kong Polytechnic University, Hong Kong, China

2. School of Electrical and Electronic Engineering, Nanyang Technological University, Singapore 639798, Singapore

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